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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/017,990	12/14/2001	Xiaoju Wu	TI-31214	8404

23494 7590 04/21/2006

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P O BOX 655474, M/S 3999  
DALLAS, TX 75265

EXAMINER
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FARAHANI, DANA

ART UNIT	PAPER NUMBER
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2891

DATE MAILED: 04/21/2006

Please find below and/or attached an Office communication concerning this application or proceeding.



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APPLICATION NO./ CONTROL NO.	FILING DATE	FIRST NAMED INVENTOR / PATENT IN REEXAMINATION	ATTORNEY DOCKET NO.
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EXAMINER
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ART UNIT	PAPER
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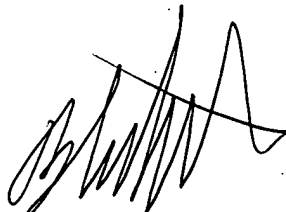
20061013

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Commissioner for Patents

The Examiner's Answer of 11/4/03 was returned from the Board of Patent Appeals and Interferences due to lack of examiner's initials. The Examiner's Answer has been initialed and sent to the board for reconsideration.

  
**B. WILLIAM BAUMEISTER**  
SUPERVISORY PATENT EXAMINER  
TECHNOLOGY CENTER 2800

DF  
April 13, 2006

**DETAILED ACTION**

***Acknowledgement of Reply Brief***

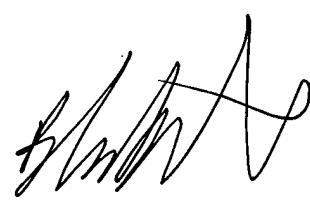
The reply brief, and the request for oral hearing filed on 12/8/03 have been entered and considered. The application has been forwarded to the board of Patent Appeals and Interferences for decision on the appeal.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Dana Farahani whose telephone number is (571)272-1706. The examiner can normally be reached on M-F 9:00AM - 5:00PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Bill Baumeister can be reached on (571)272-1722. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

D. Farahani



**B. WILLIAM BAUMEISTER**  
SUPERVISORY PATENT EXAMINER  
TECHNOLOGY CENTER 2890



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**MAILED**

NOV 05 2003

**GROUP 2800**

**BEFORE THE BOARD OF PATENT APPEALS  
AND INTERFERENCES**

Paper No. 13

Application Number: 10/017,990  
Filing Date: December 14, 2001  
Appellant(s): WU ET AL.

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Peter McLarty  
For Appellant

**EXAMINER'S ANSWER**

This is in response to the appeal brief filed 8/15/03.

Available Copy

**(1) *Real Party in Interest***

A statement identifying the real party in interest is contained in the brief.

**(2) *Related Appeals and Interferences***

A statement identifying the related appeals and interferences which will directly affect or be directly affected by or have a bearing on the decision in the pending appeal is contained in the brief.

**(3) *Status of Claims***

The statement of the status of the claims contained in the brief is correct.

**(4) *Status of Amendments After Final***

The appellant's statement of the status of amendments after final rejection contained in the brief is correct.

**(5) *Summary of Invention***

The summary of invention contained in the brief is correct.

**(6) *Issues***

The appellant's statement of the issues in the brief is correct.

**(7) Grouping of Claims**

The rejection of claims 1-30 stand or fall together because appellant's brief does not include a statement that this grouping of claims does not stand or fall together and reasons in support thereof. See 37 CFR 1.192(c)(7).

**(8) Claims Appealed**

The copy of the appealed claims contained in the Appendix to the brief is correct.

**(9) Prior Art of Record**

5,179,432	HUSHER	1-1993
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5,399,510	TANIGUCHI	3-1995
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S.M. Sze, Semiconductor Devices, Physics and Technology, 1985, John Wiley & Sons, 1<sup>st</sup> edition, page 139.

**(10) Grounds of Rejection**

The following ground(s) of rejection are applicable to the appealed claims:

Claims 1, 2, 4-6, 8, 13, 15, 17, 21-24, 27, 29, and 30 are rejected under 35 U.S.C. 102(b) as being anticipated by Husher.

Regarding claims 1, 8, 13, 15, 17, 21-24, 27, 29, and 30, Husher discloses in figure 3 an electronic circuit, comprising: a semiconductor substrate 100; a first layer 110 in a fixed physical relation to the semiconductor substrate; a well 160 formed in the first layer, wherein the well comprises a first conductivity type and has a side dimension

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and a bottom dimension; a first enclosure 180, and 170, surrounding the side dimension and the bottom dimension of the well, wherein the first enclosure comprises a second conductivity type complementary of the first conductivity type and has a side dimension and a bottom dimension; and a second enclosure (190 and substrate 100) surrounding the side dimension and the bottom dimension of the first enclosure, wherein the second enclosure comprises the first conductivity type.

Regarding claim 2, layer 150 is a buried layer (see column 4, lines 53-56).

Regarding claim 4, layer 170 is adjacent layer 150.

Regarding claim 5, layer 110 is an epitaxial layer (see column 4, lines 53-60).

Regarding claim 6, see figure 3.

Claims 3, 7, 10, 14, 25, 26, and 28 are rejected under 35 U.S.C. 103(a) as being unpatentable over Husher, further in view of Taniguchi.

Regarding claims 3, 7, 10, 14, and 25, Husher discloses the claimed invention, as discussed above, except for the first conductivity type being n-type, and the second conductivity type being p-type. Taniguchi teaches at column 7, lines 5-9, that PNP and NPN transistors are equivalently produced in the art. It would have been obvious to one of ordinary skill in the art at the time of the invention to make the first conductivity type n-type, and the second conductivity type p-type in order to make a PNP bipolar transistor instead of an NPN bipolar transistor, since they are both used in the art according to a particular application.

Regarding claims 26 and 28, Husher discloses a dosage of  $5 \times 10^{15}$  for buried layer 170 with an energy of 80 KeV (see column 4, lines 63-68).

Husher does not disclose an energy on the order of 60 KeV.

It would have been obvious to one of ordinary skill in the art at the time the invention was made to lower the energy in order to adjust the ion implantation process with the existing ion implanting environment, that is temperature and time, and also, it has been held that discovering an optimum value of a result effective variable involves only routine skill in the art. *In re Boesch*, 617 F.2d 272, 205 USPQ 215 (CCPA 1980).

Claims 9, 11, 12, 16, 18, 19, and 20, are rejected under 35 U.S.C. 103(a) as being unpatentable over Husher as applied to claims 8 above, and further in view of Semiconductor Devices, Physics and Technology.

Husher renders the claimed invention obvious, as discussed above, except for a circuitry connecting the first terminal (first enclosure) to the second terminal (second enclosure).

Size discloses on page 139, figure a, and the paragraph above the figure, a circuitry at the left hand side of the figure for connecting the base of a bipolar transistor to the emitter in order to obtain the switching characteristic of the transistor, shown below figure "a". The first enclosure and the second enclosure are emitter and base, respectively. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to use a circuitry to connect the base and emitter in order to obtain the switching characteristic of the bipolar transistor in Husher's invention.



**(11) Response to Argument**

Appellants argue that the examiner's description of region 160 of figure 3 of the Husher patent being a well is incorrect. In support of this assertion, appellants explain that region 160 is called an annular P+ sinker region (column 3, lines 67-68 of the reference), while claims 1 and 22 call for a well region. Moreover, it is stated in the Appeal Brief that the word well refers to a region that has a specific function and an "electronic device" is formed therein (see page 4, the last paragraph).

The examiner maintains that the word "well" in semiconductor terminology has a broader meaning than that as defined by the appellants. First, every region in a semiconductor device (or substrate) has a specific function, otherwise it wouldn't be in the device. Second, while an electronic device, or devices might be formed in a well region, this is not necessary. The word "well" is a broad term that could be any doped region in a semiconductor substrate. U.S. patent 5,828,124 to Villa is presented to support this statement. Villa, in figure 3, calls region 46' a well region (see column 3, line 62). Incidentally, region 46' is annular, and it is just a P doped region in the device, between the emitter E and base B. Region 48 of figure 2 is also called a well region (see column 3, line 50). Region 48 is yet another P doped region in the device. Therefore, calling region 160 of the Husher reference a "well" region is in line with what is commonly understood to be a well region in the art.

For the above reasons, it is believed that the rejections should be sustained.

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Respectfully submitted,

Dana Farahani  
Examiner  
Art Unit 2814

*DF*

October 31, 2003

Conferees  
Brian Sircus  
Wael Fahmy

*Respectfully submitted,  
Brian Sircus, Long Phan & Wael Fahmy*

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